



PATENT  
Atty Dkt. AMAT/6493/ETCH/SILICON/JB

2836

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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The Application of:  
Padmapani C. Nallan, et al.  
Serial No.: 09/993,240  
Confirmation No.: Unknown  
Filed: November 13, 2001  
For: Apparatus For Controlling  
A Thermal Conductivity  
Profile For A Pedestal In A  
Semiconductor Wafer  
Processing Chamber

OFFICIAL DRAFTSPERSON  
Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Group Art Unit: Unknown  
Examiner: Unknown  
Batch No.: Unknown  
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**37 CFR 1.8**

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## **SUBMISSION OF FORMAL DRAWINGS**

Attached please find two (2) sheets of formal drawings, with labels identifying the application for which they are submitted. The Examiner is requested to substitute these formal drawings for the informal drawings used during the prosecution of the subject patent application.

Any comparison fee should be charged to Deposit Account No. 20-0782/6493/BTP. Two copies of this document are enclosed for your convenience. If any additional informalities are identified by the Examiner, please contact the undersigned attorney at (713) 623-4844.

Respectfully submitted,

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